

INFORMATION DISCLOSURE STATEMENT

Applicant : Fujikawa et al.
 App. No : 10/840,192
 Filed : May 6, 2004
 For : PREPARATION METHOD FOR
 NANOMATERIAL, METAL OXIDE
 NANOMATERIAL FORMING
 COMPOSITION USED THEREIN,
 AND METAL OXIDE
 NANOSTRUCTURE
 Examiner : Edmund Lee
 Art Unit : 1791

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February 28, 2008

(Date)

Neil S. Bartfeld, Ph.D., Reg. No. 39,901

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 5 (five) references to be considered by the Examiner. Also enclosed are 3 (three) foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the receipt of a first Office Action on the merits, and presumably no fee is required. If a first Office Action on the merits was mailed before the mailing date of this Statement, the Commissioner is authorized to charge the fee set forth in 37 C.F.R. § 1.17(p) to Deposit Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 2/28/08By: Neil S. Bartfeld, Ph.D.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application No.	10/840,192
		Filing Date	May 6, 2004
		First Named Inventor	Fujikawa et al.
		Art Unit	1791
<i>(Multiple sheets used when necessary)</i>		Examiner	Edmund Lee
SHEET 1 OF 1		Attorney Docket No.	SHIGA7.088AUS

U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1	5,955,240	09-21-1999	Sato et al.	
	2	6,387,587	05-14-2002	Oomori et al.	

FOREIGN PATENT DOCUMENTS					
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ¹
	3	CARUSO, <i>Nanoengineering of Particle Surfaces</i> , Advanced Material, Vol. 13 No. 1, p. 11-22, (2001)			
	4	FUJIKAWA et al, <i>Polymer Preprints</i> , 52 nd Annual Meeting of The Society of Polymer Science, May 28-30, 2003, Nagoya, Japan Vol. 52, No 3.			✓
	5	MADOU, Marc J., <i>Fundamentals of Microfabrication: The Science of Miniaturization</i> ; Second Edition, CRC Press, Washington, D.C., pp. 66-67, (2002)			

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /EL/

Examiner Signature	/Edmund Lee/	Date Considered	09/17/2008
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

T¹ - Place a check mark in this area when an English language Translation is attached.